

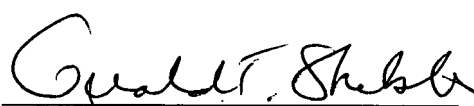


ITW

PATENT
Attorney Docket No. 1110/90738

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-----------------------------------|---|---|
| In Re U.S. Patent Application |) | Confirmation No.: 1669 |
| |) | |
| Applicants: Satoshi Komiya et al. |) | <i>I hereby certify that this correspondence is</i> |
| |) | <i>being deposited with the United Postal</i> |
| Serial No.: 10/679,031 |) | <i>Service as first class mail in an envelope</i> |
| |) | <i>addressed to: Mail Stop AMENDMENT,</i> |
| Filed: October 3, 2003 |) | <i>Commissioner for Patents, P.O. Box 1450,</i> |
| |) | <i>Alexandria, Virginia 22313-1450.</i> |
| For: EPITAXIAL SILICON WAFER |) | |
| |) | <u>June 22, 2007</u> |
| Examiner: Matthew J. Song |) | |
| |) | |
| Art Unit: 1765 |) | |


Gerald T. Shekleton, Reg. No. 27,466

AMENDMENT

Mail Stop: AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Office Action of February 23, 2007, has been carefully reviewed and the following amendments and remarks are made in response thereto.